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SERIAL NUMBE 09/927,444	1 00,10,2001		C /			2812	2842 2-12-5		ATTORNEY DOCKET NO. 6217/Consilium/DV	
Richard Dar	Ward, San J nielson, Pleas rey, Sandy, I	santon, CA;	Cop							
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** FOREIGN APP	LICATIONS		····	\					/	
IF REQUIRED, FO ** 09/21/2001			GRANTE	D				_/		
Foreign Priority claimed 35 USC 119 (a-d) condit met Verified and Acknowledged	— yeş	☑ no ☐ Met aft	er itials	STATE OR COUNTRY CA	SHE DRAV 1	VING	TOTA CLAI	MS	INDEPENDEN CLAIMS	
ADDRESS Patent Counsel, M Legal Affairs Dept Applied Materials, P.O. Box 450A Santa Clara, CA S	inc.		_							
TITLE										
Dynamic control of	f wafer proce	essing paths in	semicon	ductor manuf	acturing	proces	ses			
RECEIVED	CEIVED No to charge/credit DEPOSIT ACCOUNT					All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit				